



IN SITU REDUCTION OF COPPER OXIDE PRIOR TO SILICON CARBIDE DEPOSITION

Sophie, et al.

Appl. No.: 09/975,466 Atty Docket: ASMMC.036AUS

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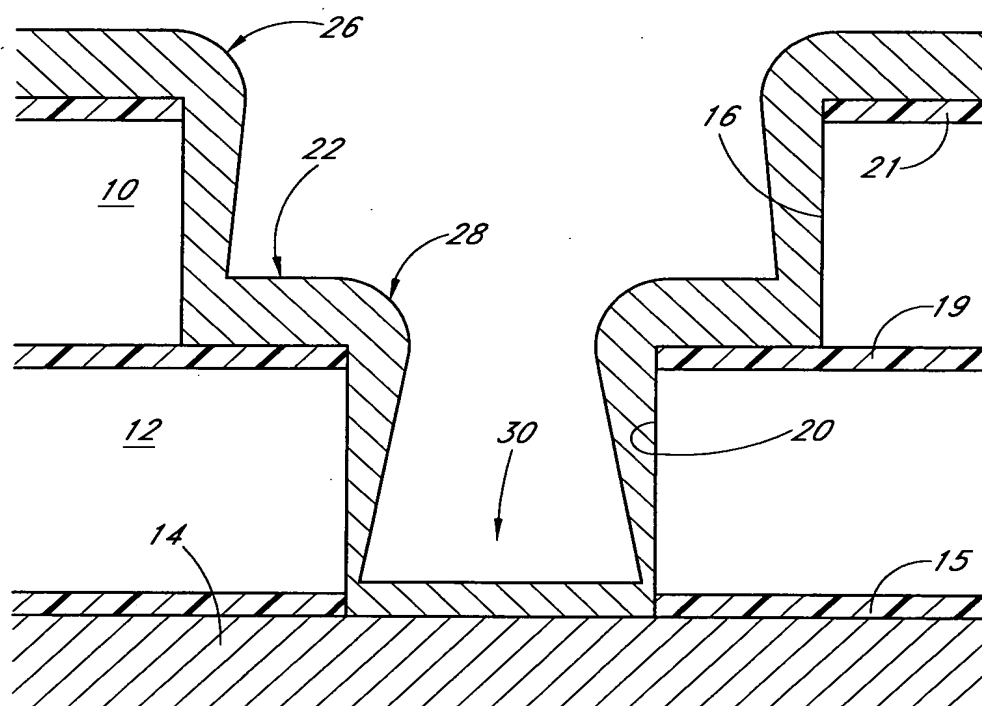


FIG. 1
(PRIOR ART)

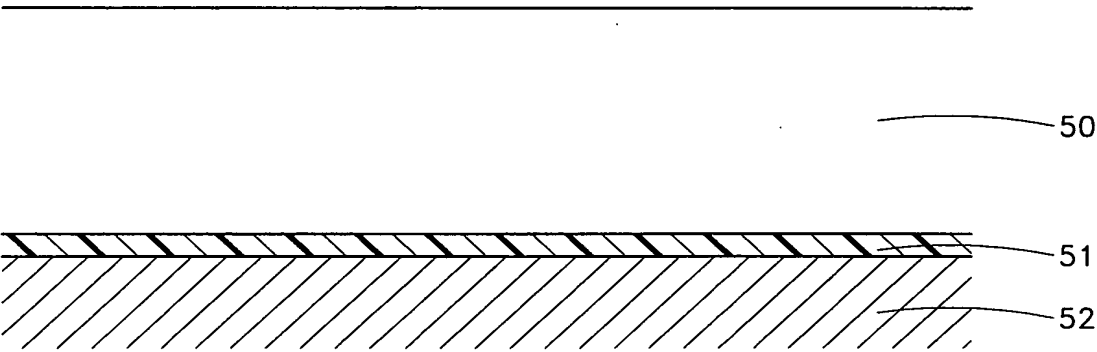


FIG.2

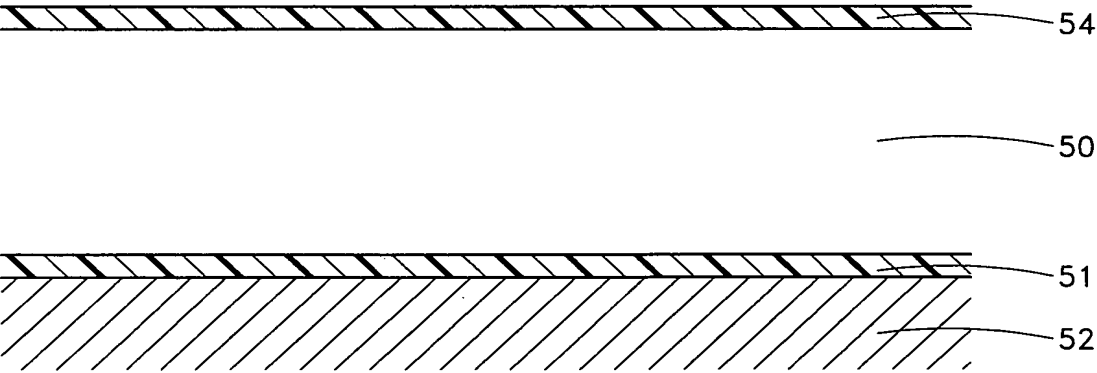


FIG.3

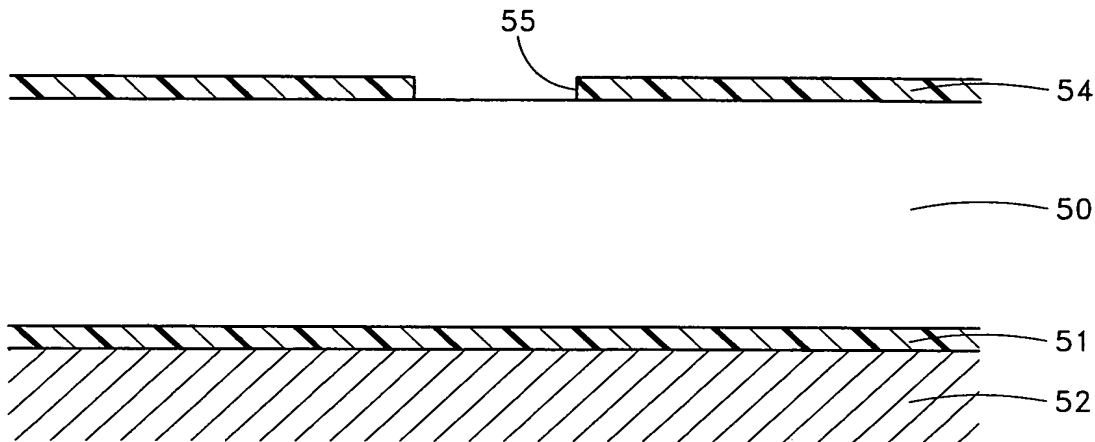


FIG. 4

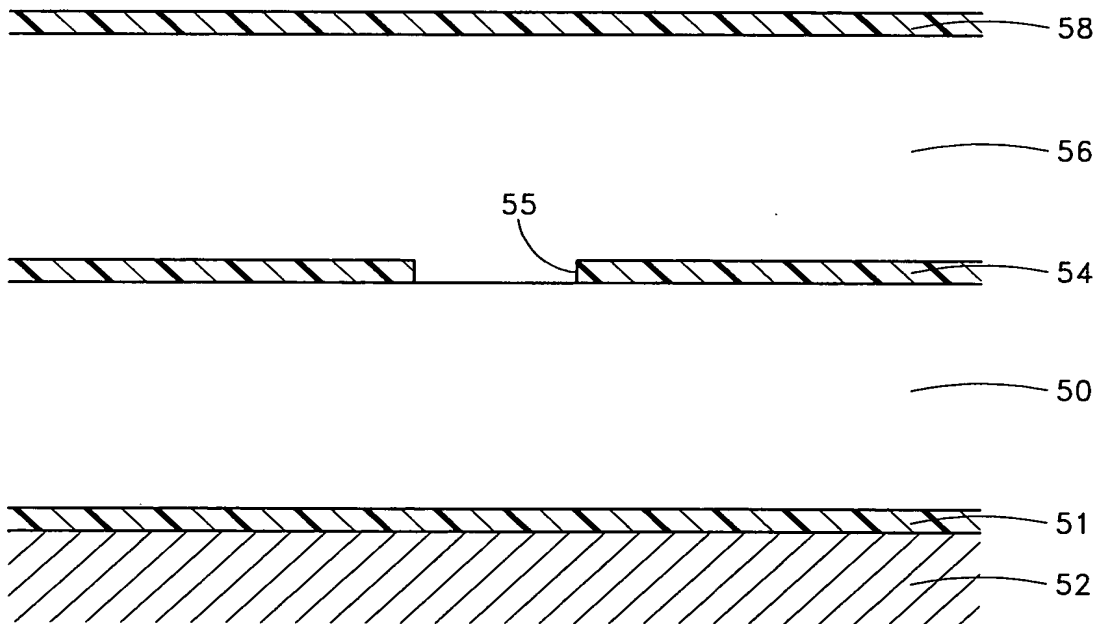


FIG. 5

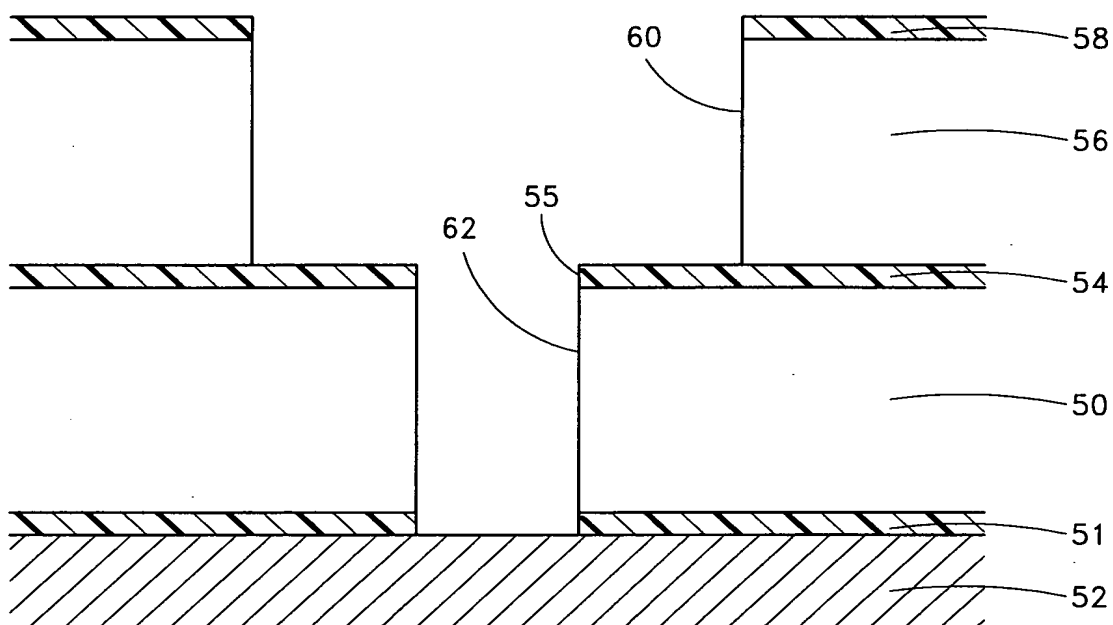


FIG. 6



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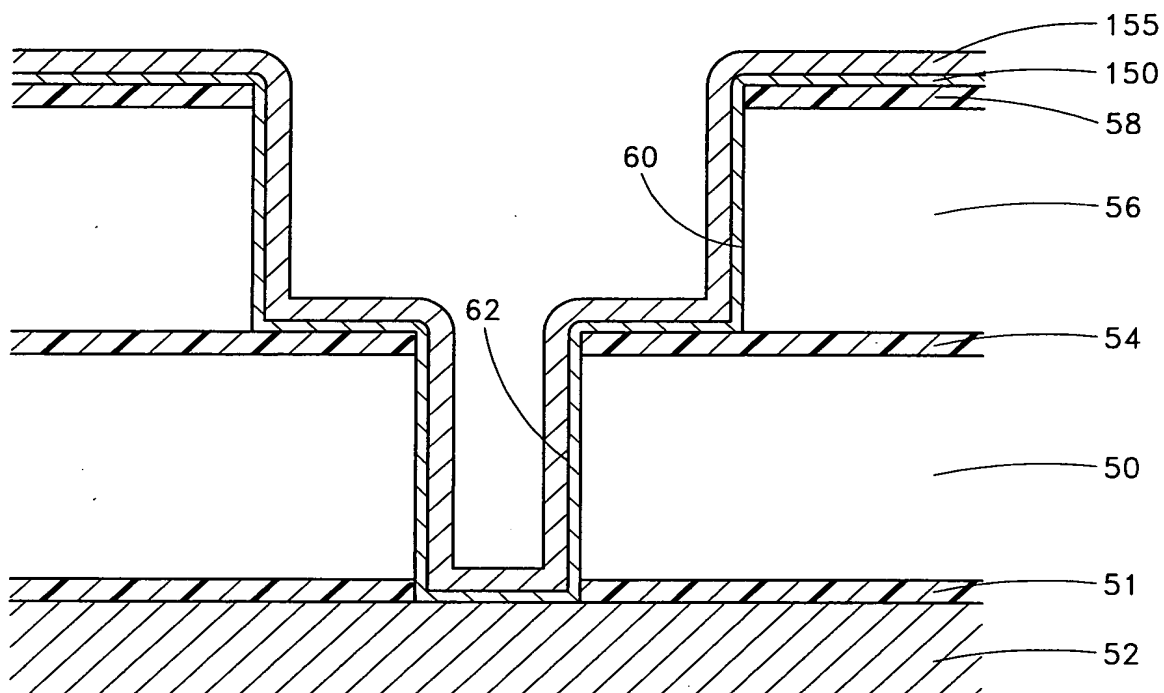


FIG. 7

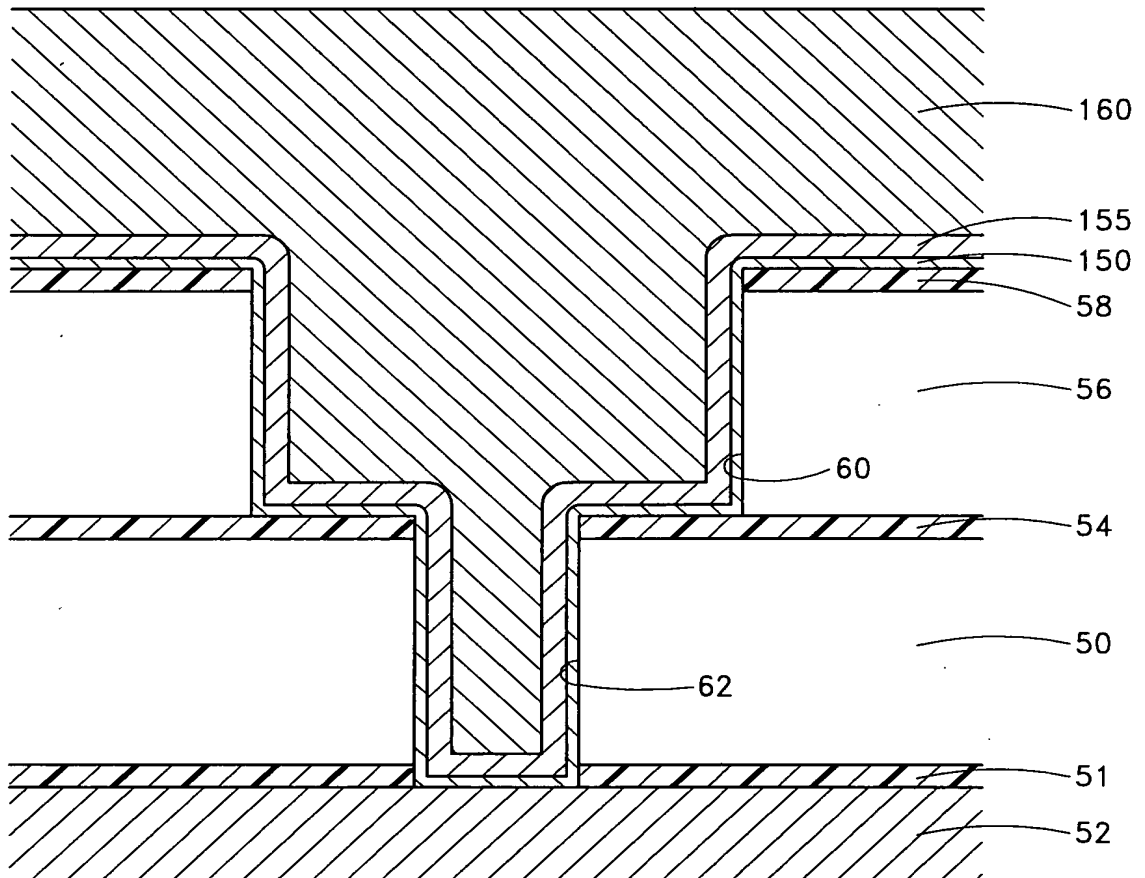


FIG. 8



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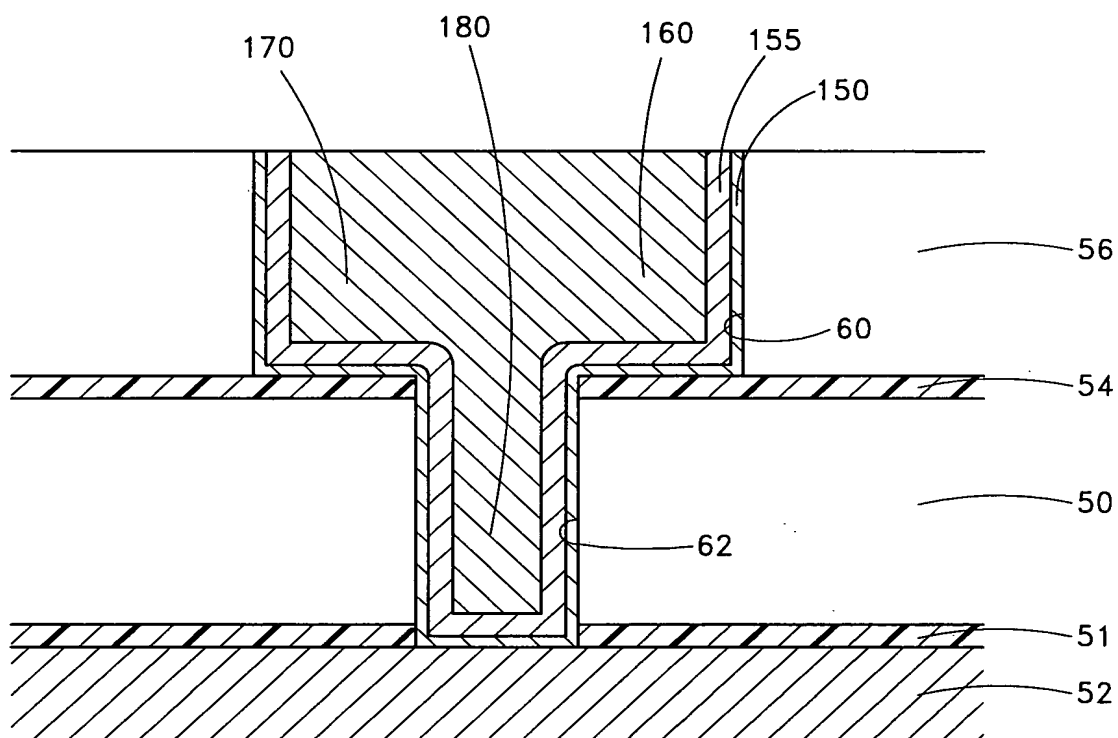


FIG. 9

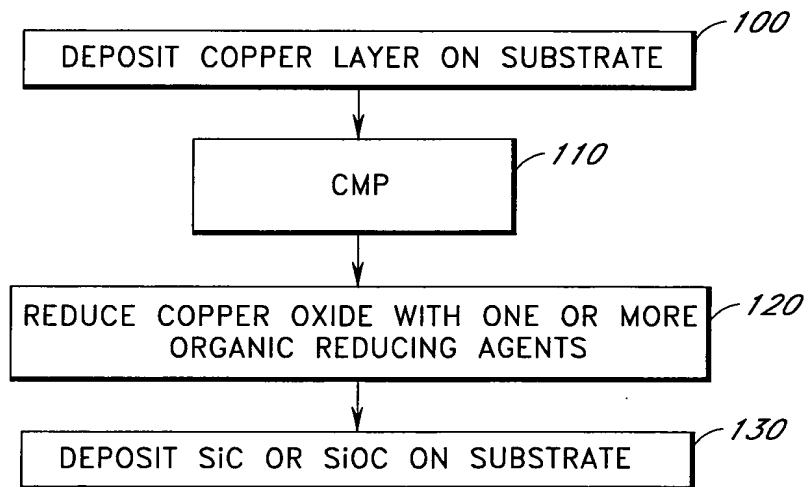


FIG. 10



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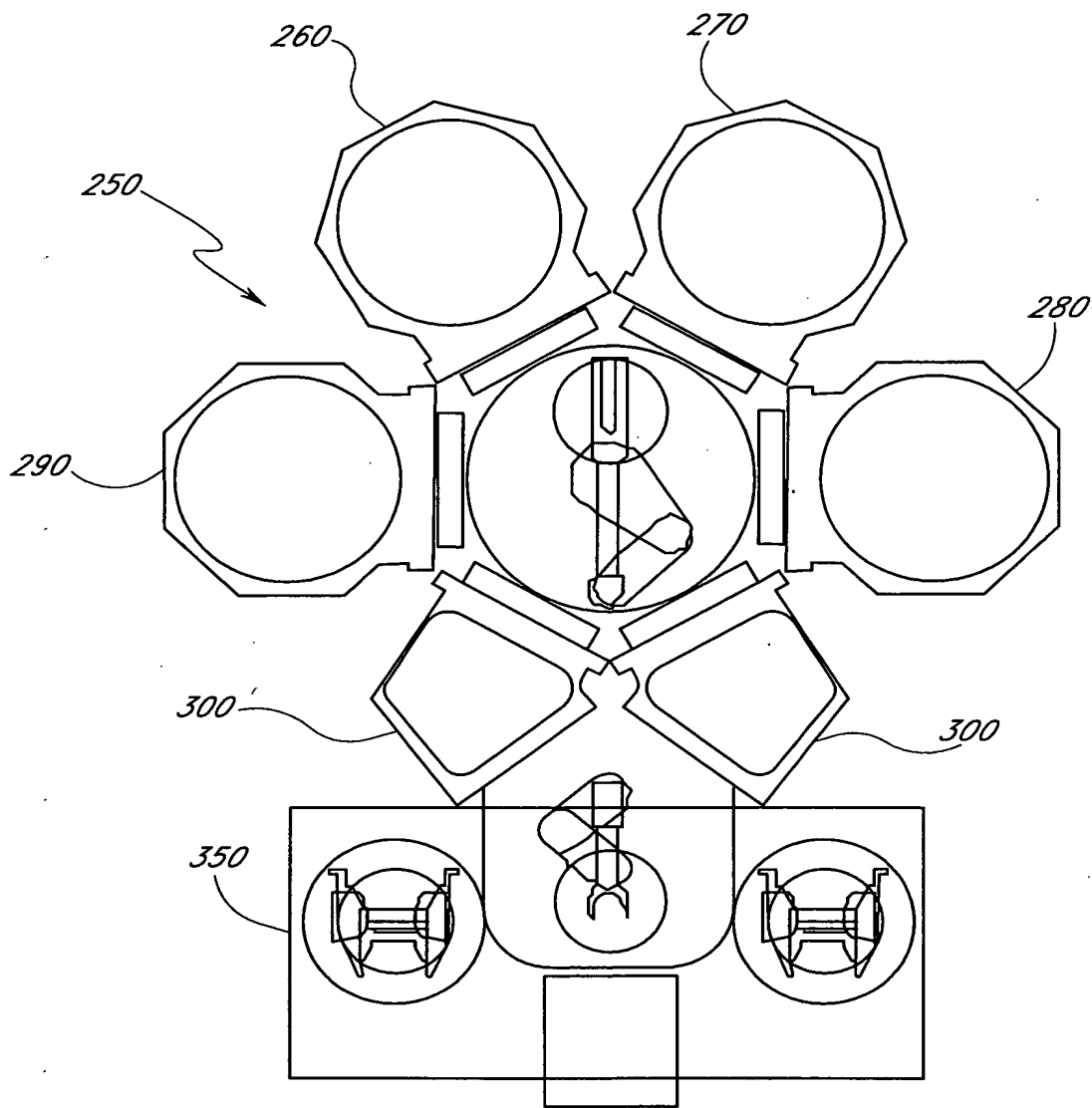


FIG. 11